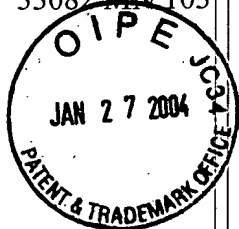


Attorney Docket:
33082 MN 103



P A T E N T

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

CONFIRMATION NO. 9454

Applicants : Wenling Wang, et al.

U.S. Serial No.: 09/963,381

Group Art Unit: 2812

Filed: : September 27, 2001

Examiner: Hoang Tu BA

For : HEAT TREATMENT APPARATUS AND CONTROLLER FOR HEAT
TREATMENT APPARATUS AND CONTROL METHOD FOR HEAT
TREATMENT APPARATUS

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Sir:

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Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants enclose an Information Disclosure Citation Form (PTO-1449) and copies of the four documents cited therein. It is respectfully requested that the cited documents be considered by the Examiner, that they be made officially of record therein, and that these documents be listed on the face of any patent which may issue from this application.


An Official Action on the merits has issued for this application. In accordance with the requirements of 37 C.F.R. §1.97(c), Applicants attach a check which includes payment of the \$180 requisite fee (37 C.F.R §1.17(p)).

Respectfully submitted,
SMITH, GAMBRELL & RUSSELL, LLP

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Date : January 27, 2004

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FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT 	ATTY. DOCKET 33082 M 103	SERIAL NO. 09/963,381
	APPLICANTS: Wenling WANG, et al..	
	FILING DATE September 27, 2001	GROUP ART UNIT 2812

U.S. PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE, IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

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FOREIGN PATENT DOCUMENTS

*Examiner's Initials		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION YES NO	
	AH	2000 / 29526 ✓	January 28 2000	JAPAN			Abstract	
	AI	09 / 007963 ✓	January 10 1997	JAPAN			Abstract	
	AJ	2000 / 077345 ✓	March 14 2000	JAPAN			Abstract	
	AK	10 / 335340 ✓	December 18 1998	JAPAN			Abstract	

OTHER INFORMATION (Including Author, Title, Date, Pertinent Pages, Etc.)

	AL	
	AM	
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	AP	
	AQ	
	AR	
	AS	
	AT	

EXAMINER:	DATE CONSIDERED:
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.